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Thin Film Technologies in Sensors Fabrication

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Deadline for manuscript
submissions:

closed (31 March 2021)

Message from the Guest Editor

Dear Colleagues,

The goal of this Special Issue on *Thin Film Technologies in Sensor Fabrication* is to give a survey of the state-of-the-art on organic and inorganic thin-film-based sensors and introduce recent progress achieved in the fabrication and application of these devices.

All who conduct research in this area and have results that contribute to the further development of thin-film-based sensors are invited to participate in our project. You can contribute both original research papers and reviews to this Special Issue.

- chemical sensors; physical sensors; optical sensors; biosensors
- gas sensors; flexible sensors; humidity sensors; temperature sensors; pressure sensors; thin-film sensor arrays
- design; fabrication; microfabrication; testing; detection principles; optimization
- sensing materials; metal oxides; polymers; carbon; electrodes
- deposition technologies

Prof. Ghenadii Korotcenkov
Guest Editor



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Special Issue



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Message from the Editor-in-Chief

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